



EFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/678,045 Confirmation No. : 6655
First Named Inventor : Hiroshi SHINRIKI
Filed : October 3, 2003
TC/A.U. : 1762
Examiner : Bret P. Chen

Docket No. : 010986.52822US
Customer No. : 23911

Title : Method of and Apparatus for Processing Substrates

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY

Sir:

In response to the Office action of May 17, 2005, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.